

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 11, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG656491291

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

7.74 - 7.80 X 4.85 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.80 CARAT

F

VS 2

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry


Fluorescence

Inscription(s)

EXCELLENT


EXCELLENT

NONE

 LG656491291

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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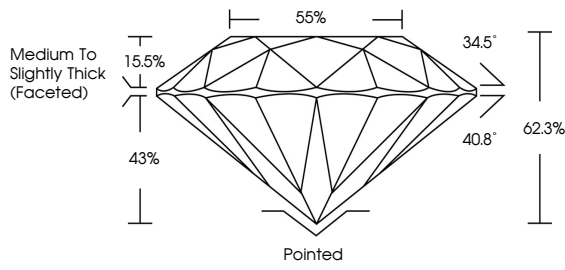
EXCELLENT

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PROPORTIONS



Medium To Slightly Thick (Faceted)

55%

34.5°

40.8°

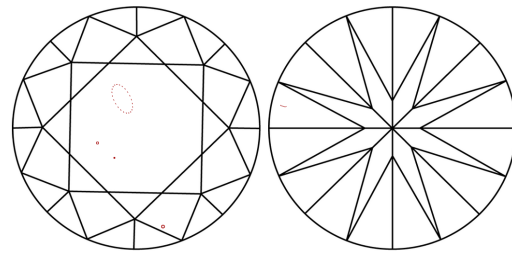
62.3%

43%

15.5%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR



D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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